



COPY OF PAPERS
ORIGINALLY FILED

Case Docket No. ASMEX.186DV1
Date: January 24, 2002
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4812
PATENT

In re application of : Raaijmakers et al.
App. No. : 09/764,711
Filed : January 18, 2001
For : METHOD OF
DEPOSITING SILICON
WITH HIGH STEP
COVERAGE
Examiner : A. Roman
Art Unit : 2812

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, D.C.
20231, on

January 24, 2002

(Date)

Adeel S. Akhlar
Adeel S. Akhlar, Reg. No. 41,394

COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Sir:

Transmitted herewith is a Response to Office Action in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	5	—	5	= 0 × \$18	= \$0
Independent Claims	1	—	1	= 0 × \$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
				TOTAL ADDITIONAL FEE FOR THIS AMENDMENT	\$0

- (X) A Supplemental Information Disclosure Statement.
(X) A PTO Form 1449 with five (5) references.
(X) A check in the amount of \$ 180 to cover the IDS above fee under 37 CFR 1.17(p).

02/26/2002 M8EBRME100000055 00754711
180.00 CP
1 FC 126

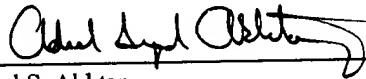
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- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



Adeel S. Akhtar

Registration No. 41,394

Attorney of Record

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